

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Armbrust et al.

Serial No.: 09/666,325

Group Art Unit: 2811

Filed: September 21, 2000

Examiner: Kang, D.

For: SELF-ALIGNED COPPER SILICIDE FORMATION FOR IMPROVED
ADHESION/ELECTROMIGRATIONAssistant Commissioner of Patents
Washington, D.C. 20231**AMENDMENT UNDER 37 C.F.R. §1.111**

Sir:

In response to the Office Action mailed June 5, 2002, please amend the application as follows.

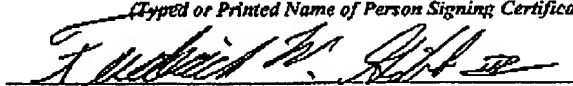
IN THE CLAIMS:

Please substitute the following claims for the same numbered claims in the application.

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CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)			Docket No. BU9-98-110 DIV
Applicant(s): Armbrust et al.			
Serial No. 09/666,325	Filing Date September 21, 2000	Examiner D. Kang	Group Art Unit 2811
Invention: SELF-ALIGNED COPPER SILICIDE FORMATION FOR IMPROVED ADHESION/ ELECTROMIGRATION			
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I hereby certify that this <u>AMENDMENT UNDER 37 CFR 1.111</u> (Identify type of correspondence)			
is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>703-872-9318</u>)			
on <u>September 5, 2002</u> (Date)			
Frederick W. Gibb, III (Typed or Printed Name of Person Signing Certificate)  (Signature)			
Note: Each paper must have its own certificate of mailing.			